

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

<i>In re</i> Application of:	Hai Cong, et al.	:	Confirmation No.:	4993
Serial No.:	10/767,292	:	Art Unit:	2812
Filed:	1/29/2004	:	Examiner:	Lynne Ann Gurley
For:	A NOVEL METHOD TO CONTROL DUAL DAMASCENE TRENCH ETCH PROFILE AND TRENCH DEPTH UNIFORMITY			

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO NON FINAL OFFICE ACTION

Madam:

The following Remarks are submitted under 37 C.F.R. §1.111 in response to the Non Final Office Action mailed July 28, 2006.

Reconsideration of the rejections is respectfully requested.